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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

SUBMISSION OF CORRECTED DRAWINGS

APPLICANTS: Fumihiko Nakamura et al. ATTY DOCKET NO: 09792909-5122
SERIAL NO.: 09/925,153 GROUP ART UNIT: 2813
DATE FILED: August 8, 2001 EXAMINER: David Blum
INVENTION: "INSULATING NITRIDE LAYER AND PROCESS FOR ITS
FORMING, AND SEMICONDUCTOR DEVICE AND PROCESS
FOR ITS PRODUCTION"

RECEIVED
MAY 14 2003
TOLSON MAIL ROOM

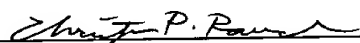
Commissioner for Patents

Alexandria, VA 22313-1450

S I R:

Applicants herewith submit corrected drawing Figures 12, 13 and 14.

Respectfully submitted,

 (Reg. No. 45,034)
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Approved
5/12/03